

Notice of References Cited	Application/Control No. 10/712,446	Applicant(s)/Patent Under Reexamination THOMAS ET AL.	
	Examiner Patricia A. George	Art Unit 1765	Page 1 of 1

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	B	US-6,620,215	09-2003	Li et al.	51/298
	C	US-5,861,005	01-1999	Kontos, Stavros B.	606/219
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NON-PATENT DOCUMENTS

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	U	Chapter 2: Characterization and Optimization of the CMP Process; Mechanics, mechanisms, and modeling of the CMP proces; Lai, jiun-Yu; MIT Thesis (Ph.D.) Dept. of Mechanical Engineering, 2001, found at the Barker Library in microforms, stacks and web-site.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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